



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Peter de Groot et al.

Art Unit : 2877

Serial No. : 10/795,808

Examiner : Unknown

Filed : March 8, 2004

Title : PROFILING COMPLEX SURFACE STRUCTURES USING SCANNING  
INTERFEROMETRY

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Prior to examination, please amend the application as indicated on the following pages.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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